

OLIFF & BERRIDGE, PLC
 ATTORNEYS AT LAW

Application Data Sheet

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Ryoji
Family Name::	HOSHI
City of Residence::	Fukushima
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Susumu
Family Name::	SONOKAWA
City of Residence::	Fukushima
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number::	25944
----------------------------------	-------

Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	A SILICON WAFER FOR EPITAXIAL GROWTH, AN EPITAXIAL WAFER, AND A METHOD FOR PRODUCING IT
Attorney Docket Number::	122336
Total Drawing Sheets::	6
Small Entity::	No

Representative Information

James A. Oliff, Reg. No. 27,075
Kirk M. Hudson, Reg. No. 27,562
Edward P. Walker, Reg. No. 31,450
Mario A. Costantino, Reg. No. 33,565

William P. Berridge, Reg. No. 30,024
Thomas J. Pardini, Reg. No. 30,411
Robert A. Miller, Reg. No. 32,771
Stephen J. Roe, Reg. No. 34,463

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/08671	07/08/03
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-204703	07/12/02	Yes
Assignee Information			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2, Marunouchi 1-chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	